514 Reco Po PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shunichi SEKI, Hiroshi KIGUCHI, Ichio YUDASAKA and Hiroo MIYAJIMA

Application No.: U.S. National Stage of PCT/JP99/01327

Filed: November 17, 1999

Docket No.:

104741

For:

THIN FILM PATTERNING SUBSTRATE AND SURFACE TREATMENT

THEREFOR

PRELIMINARY AMENDMENT

Assistant Commissioner of Patents Washington, D. C. 20231

Sir:

Prior to initial examination, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claims 3-7, 9-11, 17, 23, 25, 27, 33, 44, 48, 54-58, 60, 62, 66-69 and 72

as follows:

Claim 3, line 1, delete "or 2".

Claim 4, lines 1-2, change "any one of claims 1 to 3" to --claim 1--.

Claim 5, lines 1-2, change "any one of claims 1 to 4" to --claim 1--.

Claim 6, lines 1-2, change "any one of claims 1 to 4" to --claim 1--.

Claim 7, lines 1-2, change "any one of claims 1 to 4" to --claim 1--.

Claim 9, lines 1-2, change "any one of claims 1 to 8" to --claim 1--.

Claim 10, lines 1-2, change "any one of claims 1 to 9" to --claim 1--.